

# Search Notes



Application/Control No.

10/787,347

Examiner

Hiep Nguyen

Applicant(s)/Patent under Reexamination

KIMURA, HAJIME

Art Unit

2816

## SEARCHED

Class	Subclass	Date	Examiner
327	108	07.12.05	HA
	109	T	T
	110		
328	82		
	83		
361	104		
315	109.3	↓	↓
330	292	↓	↓

## INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
EAST	07.12.05	HA
See attachment		